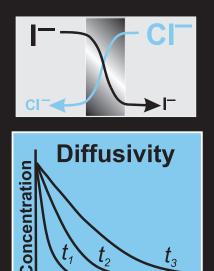


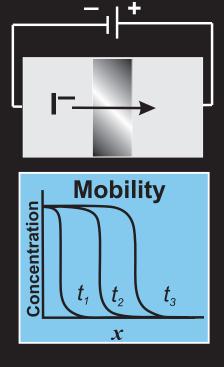
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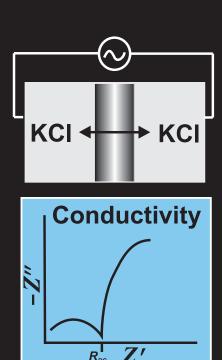
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# National Institute of Standards and Technology

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<sup>&</sup>lt;sup>1</sup>At Boulder, CO 80303.

<sup>&</sup>lt;sup>2</sup>Some elements at Boulder, CO.

# Journal of Research of the National Institute of Standards and Technology

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Cover: The three most common experimental methods used to estimate the diffusive transport coefficient of porous building materials are diffusivity, mobility, and conductivity measurements. The diffusivity and mobility measurements require on the order of weeks to months to perform for some concretes, while a conductivity measurement can be performed in a matter of minutes on the same materials. The paper by Snyder et al. (p. 497) investigates the viability of using a standardized conduction test method (ASTM C 1202), with a trivial procedural modification, to determine specimen conductivity by comparing the results to impedance spectroscopy measurements. (Cover illustration by C. Carey.) The Journal of Research of the National Institute of Standards and Technology, the flagship periodic publication of the national metrology institute of the United States, features advances in metrology and related fields of physical science, engineering, applied mathematics, statistics, and information technology that reflect the scientific and technical programs of the Institute. The Journal publishes papers on instrumentation for making accurate measurements, mathematical models of physical phenomena, including

computational models, critical data, calibration techniques, well-characterized reference materials, and quality assurance programs that report the results of current NIST work in these areas. Occasionally, a Special Issue of the *Journal* is devoted to papers on a single topic. Also appearing on occasion are review

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articles and reports on conferences and workshops sponsored in whole or in part by NIST.

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# Contents

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## Articles

Using Impedance Spectroscopy to Assess the Viability of the Rapid Chloride Test for Determining Concrete Conductivity	K. A. Snyder, C. Ferraris, N. S. Martys, and E. J. Garboczi	497
Capability in Rockwell C Scale Hardness	Walter S. Liggett, Samuel R. Low, David J. Pitchure, and John Song	511
Massic Activity Ratios of the NBS/NIST Tritiated-Water Standards Issued Between 1954 and 1999	L. L. Lucas	535
Comprehensive Review and Critical Evaluation of the Half-Life of Tritium	L. L. Lucas and M. P. Unterweger	541
Possible Advantages of a Robust Evaluation of Comparisons	Jörg W. Müller	551
Equations for the Magnetic Field Produced by One or More Rectangular Loops of Wire in the Same Plane	Martin Misakian	557
An Auto-Focusing Method in a Microscopic Testbed for Optical Discs	Xiao Tang, Pierre L'Hostis, and Yu Xiao	565
An Approach to Combining Results From Multiple Methods Motivated by the ISO GUM	M. S. Levenson, D. L. Banks, K. R. Eberhardt, L. M. Gill, W. F. Guthrie, H. K. Liu, M. G. Vangel, J. H. Yen, and N. F. Zhang	571
Numerical Evaluation of Diffraction Integrals	Klaus D. Mielenz	581
Computation of Fresnel Integrals. II	Klaus D. Mielenz	589
Thermal-Conductivity Apparatus for Steady-State, Comparative Measurement of Ceramic Coatings	A. J. Slifka	591
Treasure of the Past: III. Gravitational Anisotropy in Crystals	Paul R. Heyl	607

# Conference Reports

NIST Workshop on Luminescence Standards for	Paul C. DeRose	631
Chemical Analysis		

# News Briefs

GENERAL DEVELOPMENTS	
Predicting Nonlinear Effects in Superconducting Transmissions Baldrige Program for Education Getting Broad Support	
New Video Highlights ATP Role in Technology Innovation Industry Gives "Seal" of Approval to Remote Weld Monitoring EU Approach to Standards Explained in New NIST Guide	644
Charpy Machine Operation and Maintenance Is Easier by the Book NIST's Cryptographic Module Validation Program Validates the First Level 2 Smart Card BIPV Weather Station	645
BACnet Expands Functionality for Integrating Life Safety Systems With Other Building Automation and Control Systems NIST Develops Ultra-Narrow-Linewidth Optical Frequency Standard Definitive Article on the Fundamental Physical Constants Published in JPCRD and RMP	646
Modeling of Structural Changes in Metals The Measurement of Elastic Properties of Sprayed Coatings by Neutron Diffraction NIST Collaboration Demonstrates Optical Techniques for the Characterization of Polymer Interfaces	647
NIST Characterizes Pulsed Inductively Coupled Plasmas for Semiconductor Industry Transmission Line Probe Developed for Printed Wiring Boards Time Domain Calibrations on Ultra-Wideband Emission Sources	648
NIST Organizes First Meeting of Machine Tool Standards Committee The Forum Workshop on Measurement Needs for Fire Safety	649
NIST Sponsors Workshop on Multizone Airflow and Indoor Air Quality (IAQ) Modeling Getting It Right the First Time NIST Sponsors Third Advanced Encryption Standard (AES3) Conference	650
NIST Hosts Conference on Security Technologies and Networking NIST and Japanese Agency of Industrial Science and Technology (AIST) Hold Sixth Information Exchange	651
NIST Publishes NISTIR 6515: Semiannual Listing of the North American Quality System Registration Organizations (NAQSRO) NIST Leads International Comparison of Power and Energy Measurements NIST to Purchase Wind-Generated Electricity Thirteen Is Lucky Number for International Cooperation, Commerce	652
Partners Ensure That E-Business Is Timely Business Partnership Proposed to Reduce Duplication New MEMS Facility Opens in Boulder	653
New Standard to Help Advance Parallel Computing Agreement Streamlines Telecommunications Product Approvals	654

Software Gives Firefighters Computerized View of Deadly Blaze Ground Broken for World's Premier Metrology Research Lab	655
New Publication Helps Find State Programs for Tech Growth New Noise Measurement System Now in Service at NIST New NIST Reference Data for Electron Interactions Used by Semiconductor Industry Optical Dielectric Function Database Facilitates Compound Semiconductor Material Quality Control	656
NIST Releases Non-Blocking Versions of Message Passing Interface (MPI) Data-Type Tools NIST-Sematech Scientists Unravel the Structure of Nanoporous Thin Films	657
Evaluating Ferroelectric Materials for Microwave Electronics New Method for Materials Measurements at Very High Temperatures Photon Emission STM Provides Chemical Contrast Map of Organic Monolayers	658
Faster Algorithm Allows Improved Simulation of Single Electron Pumps New Nanometer-Scale Optical Probes Developed 30 Years of Precision Measurement Grants	659
ISO Working Group Meets at NIST Summer School on Neutron Small-Angle Scattering and Reflectometry	660
NIST Holds First Dislocation Conference of the Century—Dislocations 2000 Nanotribology Workshop Held at NIST ASTM MEMS Standards Committee Pursues NIST's Recommendations for Two New MEMS Standards	661
NIST Co-Organizes Interdisciplinary Meeting on Mathematical Aspects of Materials Science NIST Co-Sponsors First International Common Criteria Conference	662
NIST Hosts Technical Seminar on Network Security NIST Co-Sponsors Digital TV (DTV) Symposium NIST Assists in Airflow Modeling of Laboratory Facility	663
UJNR Meeting Hosted by NIST NIST Holds Workshop on Metrology and Modeling of Color and Appearance Workshop on Estimating Uncertainties for Low-Level Radiochemical Analyses Held at NIST NIST Participates in EUV-LLC Advisory Board Meeting	664
STANDARD REFERENCE MATERIALS  New Standard Reference Material Developed for the Lubricants Industry	665